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Process control corporation - processors

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Patent us7356377 - system, method, and medium for

from an advanced manufacturing process control system that The International Society for Optical Engineering Integrated Circuit

Implementation of in-situ particle monitor to

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Control of polysilicon on-film particulates with

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Manufacturing publications

Computer integrated manufacturing in the process industries, Process, equipment, and materials control in integrated circuit manufacturing III, SPIE.

Real-time control of etching processes:

1997 SPIE--The International Society for Optical Engineering. Presented at Process, Equipment, and Materials Control in Integrated Circuit Manufacturing III,

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Conference Proceedings; SPIE Digital Library; Optical Design & Engineering; Evaluation of model predictive control in run-to-run processing in semiconductor

Application of rf sensors for real-time control of

Conference Proceedings; SPIE Digital Library; Optical Engineering; Information for The rf sensor was installed only in the bias power circuit between the

Brevet us7201936 - method of feedback control of

process includes (a) The method can be used to provide feedback to a plurality of deposition chambers or to control a film property other than film

Modeling of oes data to estimate etch rate for

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